

Equipment Semi

Item #	MNFR	Model	Asset Description	Size
3619	ADT	921	CLF Chiller	
2045	AITEC Corp.	AR-S300H		12"
2042	AITEC Corp.	AR-S300H+AL		12"
2043	AITEC Corp.	AR-S300H+AL		12"
2044	AITEC Corp.	AR-S300H+AL		12"
3659	AMAT	Centura	EPI	12"
3656	AMAT	Endura 5500	PVD	6"
3341	AMAT	P5000	CVD	8"
3665	AMAT	P5000	Metal Etch	6"
3668	AMAT	P5000	PECVD	6"
3681	AMAT	P5000	RIE	6"
3688	AMAT	P5000 MarkII		
3687	AMAT	WF-736DUV	Defect Inspection	8"
2051	Amerimade	NH4OH & H2O2 drum dispenser		12"
2057	ATI		demounter	12"
2058	ATI		demounter	12"
2059	ATI		demounter	12"
2060	ATI		demounter	12"
3099	BBS Kinmei	E-300 Type II edge polisher		12"
3637	Binder	VD115	Oven	
3607	Blue M	FRP-381B-1	Environmental Chamber	
3612	Blue M	FRP-381B-1	Environmental Chamber	
3610	Blue M	IGF-6680-F-F4-CE	Inert Gas Oven	
3680	Chroma	58630	Prober	
3679	Chroma	58640	Prober	
3593	CST		Mini Environment	
3451	DNS	FL820L	IPA DRYER	
3544	DNS Dainippon Screen	SS-3000	Wafer Scrubber	12"
3545	DNS Dainippon Screen	SS-3000	Wafer Scrubber	12"
3678	Electroglas	EG 2001	Prober	
3677	Electroglas	EG 4090	Prober	
3120	Electroglas	EG2001	Prober (Parts Tool)	
2063	ENTEGRIS	13 PFA wafer cassettes		12"
2062	ENTEGRIS	25 PFA wafer cassettes		12"
3634	ESI	9350	Laser fuser (Parts Tool)	
3691	EVG	101	Spray Coater	8"
3642	EVG	301	Wafer Cleaner	
3645	EVG	301	Wafer Cleaner	
3664	EVG	520	Wafer Bonder	6"
3640	EVG	520	Wafer Bonder	8"
3694	EVG	620	Mask Aligner	6"
3654	EVG	620	Mask Aligner	
3685	EVG	EVG 520	Bonder	
3686	EVG	EVG 520IS	Bonder	
3684	EVG	TBM-8	Measurement System	
3641	EVG	501	Wafer Bonder	
3608	EVG	6200	Mask Aligner	
3657	EVG	520IS	Wafer Bonder	
3639	EVG	Gemini	Automated Wafer Bonder	
3669	Expertech Thermco	Maxibute	Diffusion Furnace	8"
3692	FEI	DB235	FIB	
3655	FEI	DB235	FIB	
3655	FEI	DB235	FIB	
3450	FEI	EXPIDA 1255S		
3471	FEI	EXPIDA 1255S		
3666	FEI	XL855 Altura	FIB	8"
2030	Fujikoshi Machinery	LPD-300		12"

2031	Fujikoshi Machinery	LPD-300		12"
2032	Fujikoshi Machinery	LPD-300		12"
2033	Fujikoshi Machinery	LPD-300		12"
2034	Fujikoshi Machinery	LPD-300		12"
2019	Fujikoshi Machinery	MCP302		12"
2020	Fujikoshi Machinery	MCP302		12"
2021	Fujikoshi Machinery	MCP302		12"
2022	Fujikoshi Machinery	MCP302		12"
2023	Fujikoshi Machinery	MCP302		12"
2024	Fujikoshi Machinery	MCP302		12"
2025	Fujikoshi Machinery	MCP302		12"
3577	GSI	M430	Laser Fuser	
3258	JEOL	JWS-7515	SEM (Not Operational)	
3627	JPSA	IX-250 ETN Chromablate	Excimer Laser System	
2143	K&S	797	Dicing Saw	
2144	K&S	797	Dicing Saw	
3609	Karl Suss	MJB3	Mask Aligner	
3690	KLA	Quantox 64100	Wafer Testing	8"
3340	KLA-Tencor	Amray 4200C	FESEM	8"
2052	Kobelco	LRP-3050Ei		12"
2053	Kobelco	LRP-3050Ei		12"
2054	Kobelco	SRP200B		12"
3693	LAM	4520XL	Etch	8"
3676	Matrix	105 CDR	System One Stripper	
3675	Matrix	105 CDR E	System One Stripper	
3674	Matrix	105R	System One Stripper	
3530	Matrix	X3	X-Ray System	
2039	Micro Engineering	LM320		12"
2046	Mitsubishi Material	A1161-1		12"
2047	Mitsubishi Material	A1161-2		12"
2048	Mitsubishi Material	A1161-5		12"
2049	Mitsubishi Material	Tamagawa 300mm final clean		12"
2050	Mitsubishi Material	Tamagawa 300mm final clean		12"
3208	Multitest	MT2168		
3673	Nanospec	Nanospec II		
2038	Napson	NC-1200WH		12"
2037	Napson	NC-3000F		12"
3590	NIKON	Eclipse E600FN	Microscope	
3660	Novellus	PEP 4800DL IRIDIA		
3663	Novellus	PEP 4800DL IRIDIA		
3697	OAI	Hybralign 200	Mask Aligner	Up to 6"
3638	Philips	PD 7400 DCD	Wafer Mapper	
3672	Plasmatherm		LAPECVD	
3671	Plasmatherm		SLR ICP	
3130	Prometrix	RS55	Resistivity Mapping System - Refurbished	8"
3649	RUDOLPH	FE IV	ELLIPSOMETER	
3317	Rudolph	AutoEI Automatic	Ellipsometer	
3625	Sandvik	LT1012	Furnace	
3280	Semitool	4300-S	Spin Rinser Dryer	8"
2172	Shinko	SWP	Organic Asher	
2141	Sopra	GES – 5	Ellipsometer	
2061	SPEC	Copper Strip	Wet Bench	12"
3631	Specialty Coating Systems	2010 Labcoter 2	Parylene Deposition	
3617	Suss Microtec	DSM8-2	Parts Tool	
3446	Suss Microtec	MA4/6	Mask Aligner - Refurbished TSA/BSA (IR)	Up to 6"
3618	SVG	VTR7000	Vertical Oxidation Furnace	

2055	Tamagawa	300mm dryer		12"
2056	Tamagawa	300mm FOSB washer		12"
3360	Tegal	981	Etcher	8"
3658	TEL	Lithius	Clean Track	12"
3452	TEL	LITHIUS	Coater/Developer	12"
3458	TEL	LITHIUS	Coater/Developer	12"
3461	TEL	LITHIUS	Coater/Developer	12"
3462	TEL	LITHIUS	Coater/Developer	12"
3667	TEL	P12XL	Prober	12"
3661	TEL	P12XLN	Prober	12"
3100	TEL	UW300Z	Strip Bench	12"
3683	TEL	Clean Track	Adhesion Spin Coater	
3542	Thomas Swan	M-Epitor	GaN MOCVD	
3662	Ueno Seiki	WS-Evo	Inspection System	
3670	Ultrasonic Sciences Ltd	SCM12Xi	Ultrasonic C scan system	
2285	Varian	938-41	Porta Test Leak Detector	
2140	Veeco	3100	AFM	
3551	VEECO EMCORE	D180	GaN MOCVD	6"x2"
3459	WYKO / VEECO	NT1100	Optical Profiling System	
3103	WYKO / VEECO	NT2000	Optical Profiler - Refurbished	
3101	WYKO / VEECO	NT3300	Optical Profiler - Refurbished	
3102	WYKO / VEECO	NT8000	Optical Profiler - Refurbished	